

1763

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APR 22 2003

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Application Number	09/418,818
Filing Date	October 15, 1999
First Named Inventor	Cheung, David
Art Unit	1763
Examiner Name	Rudy Zervigon
Attorney Docket Number	1084D01T9320
Total Number of Pages in This Submission	

ENCLOSURES (Check all that apply)

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Firm or Individual	Townsend and Townsend and Crew LLP Chun-Pok Leung Reg. No. 41,405
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Date	4-14-03

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PATENT
Attorney Docket No.: 1084D01T9320
TTC Ref. No.: 016301-009320

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#20F
4/24/03
mw

In re application of:

David Cheung et al.

Application No.: 09/418,818

Filed: October 15, 1999

For: METHOD AND APPARATUS FOR
DEPOSITING ANTIREFLECTIVE
COATING

Examiner: Rudy Zervigon

Art Unit: 1763

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

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Sir:

In response to the Office Action mailed January 14, 2003, please amend the above-identified application as follows:

IN THE CLAIMS:

Please cancel claims 7 and 8 without prejudice; and amend claims 1, 44, 49, 53, 54, 55, 57, and 62 as follows. The remaining claims are unamended, but are reproduced below for the Examiner's convenience and reference.

1. (Amended) A substrate processing system, comprising:
a vacuum chamber;
a substrate supporter, located within the vacuum chamber, for holding a substrate;

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